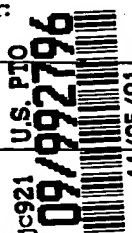


Substitute for Form 1449A/PTO (Unfiled) (use as many sheets as necessary)		Attorney Docket No. 042390P8122D	Application Number: Not yet assigned
		First Named Inventor: Peng Cheng et al.	
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U.S. PATENT DOCUMENTS

Exam. Initial*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (If known)			
DF		5,629,061		Goldsmith	4/8/1997	
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OTHER ART - NO PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	
DF		Kevin F. Harsh et al, "Flip-Chip Assembly for Si-Based RF MEMS", IEEE, MEMS '99 Conference, 12 th Intl. Conference, pp 273-278, December 1999	
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DF		International Search Report, PCT/US 01/02202, January 22, 2001	

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